

SON-2612/DIV

## PATENT APPLICATION



In re the Patent Application of Koichiro Kishima et al

Application No.: 10/785,005

Art Unit: 2811

Filed: February 25, 2004

Conf. No. 9742

For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Submitted herewith on Form PTO-1449 or PTO/SB/08 is a listing of documents known to Applicant in order to comply with Applicant's duty of disclosure pursuant to 37 CFR 1.56. Applicant respectfully requests that the listed documents be considered by the Examiner and formally be made of record in the present application and that an initialed copy of Form PTO-1449 or PTO/SB/08 be returned in accordance with MPEP §609.

As provided in 37 CFR §1.98(d), copies of the documents are not being provided since they were previously cited by or submitted to the Patent Office in parent application Serial No. 10/390,768, filed March 19, 2003.

## Concise Explanation of Relevancy of the Document

(Fill out if no English translation, partial translation or English abstract is available)

Any document having neither English translation nor English abstract relates to the subject matter of the above-identified application. English translation of the document is not readily available; however, the absence of such translations does not relieve the PTO from its duty to consider the submitted document (37 C.F.R. §1.98 and MPEP §609).

1. This Information Disclosure Statement is being filed within three months of the U.S. filing date or within three months from the date of entry of the national stage as set forth in 37 C.F.R. §1.491 in compliance with 37 C.F.R. §1.97(b), OR is being filed concurrent with filing of the Continued Prosecution Application (CPA) or the Request for Continued Examination (RCE). No fee is required (37 C.F.R. §1.97(b)).

Dated: September 29, 2004

Respectfully/submitted,

Ronald P. Kananen

Registration No.: 24,104

RADER, FISHMAN & GRAUER PLLC

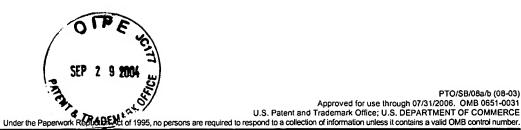
123/3 20th Street, N.W.

Suite 501

Washington, DC 20036

(202) 955-3750

Attorneys for Applicant



PTO/SB/08a/b (08-03)
Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Complete if Known Substitute for form 1449A/B/PTO 10/785,005 Application Number INFORMATION DISCLOSURE February 25, 2004 Filing Date STATEMENT BY APPLICANT First Named Inventor Shigeru Fujita Art Unit 2811 (Use as many sheets as necessary) Examiner Name N/A Sheet of 1 Attorney Docket Number **SON-2612/DIV** 

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2</sup> ( if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
-	AA		12-02	Shih et al		
	AB	6,387,761	05-02	Shih et al		
	AC	6,339,246	01-02	Kizilyalli et al		
	AD	6,482,694	11-02	Chittipeddi et al		
	AE	2002/0043679	04-02	Miki et al		
	AF	2002/0014666	02-02	Ohmi et al		
	AG	2001/0016394	08-01	Koyanagi et al		
	AH	6,048,769	04-00	Chau, Robert S.		
	ΑI	6,538,278	03-03	Chau, Robert S.		
	AJ	6,607,952	08-03	Yagishita et al		
	AK	6,037,235	03-00	Narwankar et al		
	AL	2003/0194853	10-03	Jeon, Joong		
	AM	6,436,848	08-02	Ramkumar, Krishnaswamy		
	AN	6,251,761	06-01	Rodder et al		
	AO	6,407,435	06-02	Ma et al		
	AP	6,693,004	02-04	Halliyal et al		
	AQ	6,664,186	12-03	Callegari et al		
	AR	2002/0137317	09-02	Kaushik et al		
	AS	6,376,888	04-02	Tsunashima et al		
	AT	6,586,349	07-03	Jeon et al		
	AU	6,642,573	11-03	Halliyal et al		

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	<b>⊤</b> ⁵		
	BA							

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
	CA		

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.

Examiner	Date
Signature	Considered